ATTORNEY DOCKET 021208.0247

PATENT APPLICATION 10/706,637

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jacque C.S. Kools et al.

Date Filed:

November 12, 2003

Serial No.:

10/706,637

Examiner:

Unknown

Title:

Method and Apparatus for Fabricating a Conformal

Thin Film on a Substrate

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

I hereby certify that this Information Disclosure Statement is being deposited with the United States Postal Service as Express Mail No. <u>EV352391129US</u> addressed to: Box: Commissioner for Patents, Alexandria, VA 22313-1450, on February 10, 2004.

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§1.56, 1.97, and 1.98, that the references listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Copies of the references are enclosed for the convenience of the Examiner. Since the present Application was filed after June 30, 2003, a copy of any U.S. Patent and any U.S. Patent Application Publication cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure Statement pursuant to the July 11, 2003 waiver of 37 C.F.R. S 1.98(a)(2)(i) by the U.S. Patent and Trademark Office.

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Furthermore, pursuant to 37 C.F.R. §§1.97 (g) and (h), no representation is made that these references are material to the patentability of the present application.

Applicants believe no fees are due, however, the Commissioner is hereby authorized to charge any fee to Deposit Account No. 50-2148 of Baker Botts L.L.P. in order to effectuate this filing.

Respectfully submitted,

BAKER BOTTS L.L.P. Attorneys for Applicants

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Applicant(s) PTO-1449 Application No. 10/706.637 Jacque C.S. Kools et al. Information Disclosure Citation **Docket Number Group Art Unit** Filing Date in an Application 021208.0247 Unknown 11/12/2003 **U.S. PATENT DOCUMENTS** DOCUMENT NO. DATE **CLASS** SUBCLASS **FILING DATE** NAME 07/15/97 Vanell et al. 12/14/93 5647911 118 715 B. 5711811 01/27/98 Suntola et al. 118 711 11/28/95 C. 06/29/99 118 715 06/07/95 5916369 Anderson et al. D. 6387185 B2 05/14/02 Doering et al. 118 729 01/16/01 E. 05/23/01 2003/0003635 A1 01/02/03 Paranipe et al. 438 149 F. Raaijmakers 09/08/99 6511539 B1 01/28/03 117 102 G. Η. ١. J. K. FOREIGN PATENT DOCUMENTS TRANSLATION DOCUMENT NO. DATE COUNTRY **CLASS SUBCLASS** YES L. M. N. 0. P. **NON-PATENT DOCUMENTS** DATE **DOCUMENT (Including Author, Title, Source, and Pertinent Pages)** Omstead, Thomas, et al.; "Filling High-AR Structures Using Pulsed Nucleation Layer Deposition", Q. 09/2002 Solid State Technology, Vol. 45, pp. 51-56. Ritala, Mikko, et al.; "Atomic Layer Epitaxy – a Valuable Tool for Nanotechnology?", R. 1999 Nanotechnology, Vol. 10, pp. 19-24. S. Т. U. DATE CONSIDERED **EXAMINER**

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through

citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.